

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Masayuki FURUHASHI et al.**

Serial Number: **Not Yet Assigned**

Filed: **October 29, 2003**

Customer No.: **38834**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD AND SEMICONDUCTOR  
FABRICATION CONTROL METHOD**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

October 29, 2003

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,  
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Enclosures: PTO-1449; References (6 )

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|--|---|-----------------------|
| <b>INFORMATION<br/>DISCLOSURE<br/>STATEMENT<br/>PTO-1449</b> | Atty. Docket No. 032077                 | Serial No. New Appln. |
|  | Applicant(s): Masayuki FURUHASHI et al. |                       |
|  | Filing Date: October 29, 2003           | Group Art Unit:       |

### U.S. PATENT DOCUMENTS

| Examiner<br>Initial | Document<br>No. | Name | Date | Class | Subclass | Filing Date<br>(If appropriate) |
|---------------------|-----------------|------|------|-------|----------|---------------------------------|
| _____               | AA              |      |      |       |          |                                 |
| _____               | AB              |      |      |       |          |                                 |
| _____               | AC              |      |      |       |          |                                 |
| _____               | AD              |      |      |       |          |                                 |

### FOREIGN PATENT DOCUMENTS

|       | Document<br>No. | Date        | Country  | Translation<br>(Yes or No) |           |
|-------|-----------------|-------------|----------|----------------------------|-----------|
| _____ | AE              | 9-326396    | 12/16/97 | Japan                      | Abstract. |
| _____ | AF              | 2000-340644 | 12/08/00 | Japan                      | Abstract  |
| _____ | AG              | 10-313012   | 11/24/98 | Japan                      | Abstract  |
| _____ | AH              | 2001-102321 | 04/13/01 | Japan                      | Abstract  |
| _____ | AI              | 2001-102386 | 04/13/01 | Japan                      | Abstract  |
| _____ | AJ              | 2001-274154 | 10/05/01 | Japan                      | Abstract  |
| _____ | AK              |             |          |                            |           |

### OTHER DOCUMENTS

|       |    |  |
|-------|----|--|
| _____ | AL |  |
| _____ | AM |  |

|          |                 |
|----------|-----------------|
| Examiner | Date Considered |
|----------|-----------------|